



EL979949522

Inventor: **Cem Basceri**
Title: **Methods of Forming Capacitor Constructions Comprising Perovskite-Type Dielectric Materials With Different Amount of Crystallinity Regions**
Assignee: **Micron Technology, Inc.**
Serial No.: **09/932,003**
Filed: **August 17, 2001 [RCE Filed Herewith]**

INFORMATION DISCLOSURE STATEMENT

PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, the Examiner's attention is directed to the references listed on the attached Form PTO-1449 and copies of which are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Date: 1/19/04

Attorney: 

David G. Latwesen, Ph.D.
Reg. No. 38,533
Wells St. John P.S.

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Form PTO-1449

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.
MI22-1731SERIAL NO.
09/932,003LIST OF ART CITED BY APPLICANT
(Use several sheets if necessary)APPLICANT
Cem BasceriFILING DATE
Aug. 17, 2001 [RCE filed herewith]GROUP
2813

U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	6,236,076 B1	05/01	Arita et al.			
	AB	6,285,051 B1	09/01	Ueda et al.			
	AC	5,635,741	06/97	Tsu et al.			
	AD	6,422,281 B1	07/02	Ensign Jr. et al.			
	AE	6,527,028 B2	03/03	Miller			
	AF	6,602,376 B1	08/03	Bradshaw			
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AM							
	AN							
	AO							
	AP							
	AQ							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

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EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.